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Timing resolution and CCE of n-on-n silicon sensors with TCT setup

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In this work we present 2D charge maps, CCE and timing measurements performed on 3D n-on-n silicon double sided $200\mu\text{m}$ thick sensors irradiated at different fluency levels, ranging from $1\text{e}14\text{neq}/\text{cm}^2$ to $1\text{e}17\text{neq}/\text{cm}^2$ on a TCT setup using different laser intensities, mimicking the height of the signal from a beta-source setup, and some multiples of it. We show CCE above 100% at $1\text{E}15\text{neq}/\text{cm}^2$ fluency due to charge multiplication while being 40% at the extreme high fluency of $1\text{E}17\text{neq}/\text{cm}^2$, and showcasing 200ps timing resolution up to $1\text{e}15\text{neq}/\text{cm}^2$ in very big diode arrays in which timing is highly limited by its noise due to a high capacitance.

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